

PATENT ASSIGNMENT

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NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
CONVEYING PARTY DATA	
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University of California	04/02/2010
RECEIVING PARTY DATA	
Name:	National Science Foundation
Street Address:	4201 Wilson Blvd
Internal Address:	Room 1265
City:	Arlington
State/Country:	VIRGINIA
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PROPERTY NUMBERS Total: 1	
Property Type	Number
Patent Number:	6413587
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Invention Title: METHOD FOR FORMING POLYMER BRUSH PATTERN ON A SUBSTRATE SURFACE

Inventor(s): Nicholas L. Abbott, Craig J. Hawker, James L. Hedrick

U.S. Filing/Issue Date: 07/02/2002 Patent or Application Serial No.: 6,413,587

Grant/Contract Number(s): NSF 9400354

Foreign Applications filed/intended in (countries): N/A

UC Case Number: 2000-098-1

The invention identified above is a Subject Invention under **35 U.S.C. 200, et seq.**, and the Standard Patent Rights clause at **37 CFR 401.14, FAR 52.227-11** or **FAR 52.227-12** (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government. This document is confirmatory of:

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Signed this 2nd day of April, 2010

By John Shih, Ph.D.
(Name of Grantee/Contractor Official)



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Title: Business Development & Manager, Patent Prosecution

For UNIVERSITY OF CALIFORNIA
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